

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
DECLARATION FOR PATENT APPLICATION

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name.

I believe I am an original, first and joint inventor of the subject matter which is claimed and for which a patent is sought on the invention entitled:

IMPROVED PHOTOLITHOGRAPHY PROCESS USING MULTIPLE ANTI-REFLECTIVE COATINGS

The specification of which is attached hereto.

I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by an amendment, if any, specifically referred to in this oath or declaration.

I acknowledge the duty to disclose all information known to me which is material to patentability as defined in Title 37, Code of Federal Regulations, § 1.56.

I hereby claim foreign priority benefits under Title 35, United States Code § 119/365 of any foreign application(s) for patent or inventor's certificate listed below and have also identified below any foreign application for patent or inventor's certificate having a filing date before that of the application on which priority is claimed:

<b>Prior Foreign Application(s)</b>			<u>Priority Not Claimed</u>
(Number)	(Country)	(Filing Date)	<input type="checkbox"/>
_____	_____	_____	<input type="checkbox"/>
_____	_____	_____	<input type="checkbox"/>
_____	_____	_____	<input type="checkbox"/>

I hereby claim the benefit under Title 35, United States Code, § 120/365 of any United States and PCT international application(s) listed below and, insofar as the subject

matter of each of the claims of this application is not disclosed in the prior United States application in the manner provided by the first paragraph of Title 35, United States Code, § 112, I acknowledge the duty to disclose all information known to me to be material to patentability as defined in Title 37, Code of Federal Regulations, § 1.56(a) which became available between the filing date of the prior application and the national or PCT international filing date of this application:

(Application Serial No.)	(Filing Date)	(Status) (patented, pending, abandoned)

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

Please address all correspondence to Thomas J. D'Amico of Dickstein Shapiro Morin & Oshinsky LLP located at 2101 L Street NW, Washington, DC 20037-1526. Telephone calls should be made to (202) 785-9700.

Full name of first inventor: Philip J. Ireland

Inventor's signature: Philip J. Ireland Date: 8/31/99  
Residence: Nampa, Idaho  
Citizenship: United States of America  
Post Office Address: 6722 E. Locust Lane  
Nampa, ID 83686

Aug 25 99 02:24P  
08/25/99 15:52

Sapidyne Instruments

208-345-5251

NO. 991 P008

p. 3

Docket No.: M4065.0143/P143  
Micron No.: 98-0599

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
DECLARATION FOR PATENT APPLICATION

Signature Page for Second Inventor

Full name of second inventor: Thomas R. Glass

Inventor's signature:  Date: 8/25/99

Residence: Idaho City, Idaho

Citizenship: United States of America

Post Office Address: P.O. Box AB  
Idaho City, ID 83631

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
**DECLARATION FOR PATENT APPLICATION**

Signature Page for Third Inventor

Full name of third inventor: Gurtej Sandhu

Inventor's signature:

Gurtej Singh Sandhu Date: 8/31/99

Residence: Boise, Idaho

Citizenship: United Kingdom

Post Office Address: 2964 East Parkriver Drive  
Boise, Idaho 83706

MICRON PATENT DEPARTMENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Patent Application of:  
Phillip J. Ireland et al.

Serial No.: Not Yet Assigned

Group Art Unit: Not Yet Assigned

Filed: Concurrently Herewith

Examiner: Not Yet Assigned

For: IMPROVED  
PHOTOLITHOGRAPHY  
PROCESS USING MULTIPLE  
ANTI-REFLECTIVE  
COATINGS

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Assistant Commissioner for Patents  
Washington, D.C. 20231

**POWER OF ATTORNEY BY ASSIGNEE AND  
CERTIFICATE BY ASSIGNEE UNDER 37 CFR § 3.73(b)**

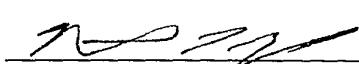
Micron Technology, Inc., assignee of the entire right, title and interest in the above-identified application by virtue of the assignment attached hereto (which is also being submitted concurrently for recordation), hereby appoints the attorneys and agents of the firm of Dickstein Shapiro Morin & Oshinsky LLP located at 2101 L Street NW, Washington DC 20037-1526, listed as follows: Gary M. Hoffman, 26,411; Thomas J. D'Amico, 28,371; Donald A. Gregory, 28,954; James W. Brady, Jr., 32,115; Jon D. Grossman, 32,699; Mark J. Thronson, 33,082; Laurence E. Fisher, 37,131; John R. Fuisz, 37,327; Brian A. Lemm, 43,748; Gianni Minutoli, 41,198; Eric Oliver, 35,307; William E. Powell, III, 39,803; James M. Silbermann, 40,413 and Salvatore P. Tamburo, P-45,153, and also attorneys of Micron Technology, Inc. as its attorneys with full power of substitution to prosecute this application and to transact all business in the Patent and Trademark Office in connection therewith.

The assignee certifies that the above-identified assignment has been reviewed and to the best of the assignee's knowledge and belief, title is in the assignee.

Please direct all correspondence regarding this application to the following:

Thomas J. D'Amico, Esq.  
Dickstein Shapiro Morin & Oshinsky LLP  
2101 L Street NW  
Washington, DC 20037-1526  
Telephone: (202) 828-2232  
Fax: (202) 887-0689

MICRON TECHNOLOGY, INC.

  
Michael L. Lynch  
Chief Patent Counsel  
Registration No. 30,871

Dated: 9-16-99

COPY

ASSIGNMENT AND AGREEMENT

For value received, we, Philip J. Ireland, Thomas R. Glass and Gurtej Sandhu hereby sell, assign and transfer to Micron Technology, Inc., a corporation of the State of Delaware, having an office at 8000 S. Federal Way, Boise, Idaho 83706-9632, U.S.A., and its successors, assigns and legal representatives, the entire right, title and interest, for the United States of America, in and to certain inventions related to an invention entitled IMPROVED PHOTOLITHOGRAPHY PROCESS USING MULTIPLE ANTI-REFLECTIVE COATINGS, described in an application for Letters Patent of the United States, executed by us of even date herewith, and all the rights and privileges in said application and under any and all Letters Patent that may be granted in the United States for said inventions; and we also concurrently hereby sell, assign and transfer to Micron Technology, Inc. the entire right, title and interest in and to said inventions for all countries foreign to the United States, including all rights of priority arising from the application aforesaid, and all the rights and privileges under any and all forms of protection, including Letters Patent, that may be granted in said countries foreign to the United States for said inventions.

We authorize Micron Technology, Inc. to make application for such protection in its own name and maintain such protection in any and all countries foreign to the United States, and to invoke and claim for any application for patent or other form of protection for said inventions, without further authorization from us, any and all benefits, including the right of priority provided by any and all treaties, conventions, or agreements.

We hereby consent that a copy of this assignment shall be deemed a full legal and formal equivalent of any document which may be required in any country in proof of the right of Micron Technology, Inc. to apply for patent or other form of protection for said inventions and to claim the aforesaid benefit of the right of priority.

We request that any and all patents for said inventions be issued to Micron Technology, Inc. in the United States and in all countries foreign to the United States, or to such nominees as Micron Technology, Inc. may designate.

We agree that, when requested, we shall, without charge to Micron Technology, Inc. but at its expense, sign all papers, and do all acts which may be necessary, desirable or convenient in connection with said applications, patents, or other forms of protection.

COPY

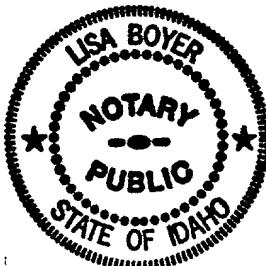
Philip J. Ireland  
Philip J. Ireland

Date: 8/31/99

United States of America )  
State Idaho )ss.:  
County of Ada )

On this 31 day of August, 1999, before me personally came Philip J. Ireland, to me known to be the individual described in and who executed the foregoing instrument, and acknowledged execution of the same.

Lisa Boyer  
Notary Public



Docket No. M4065.0143/P143  
Microfilm No. 98-0599

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**ASSIGNMENT AND AGREEMENT**

**COPY**

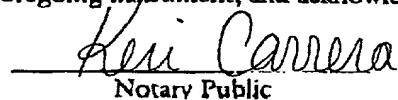
Signature Page for Second Inventor

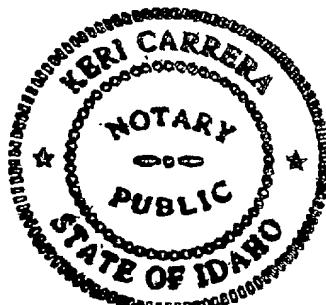
  
Thomas Glass

Date: August 25, 1999

United States of America )  
State Idaho )ss.:  
County Ada )

On this 25th day of August, 1999, before me  
personally came Thomas Glass, to me known to be the  
individual described in and who executed the foregoing instrument, and acknowledged  
execution of the same.

  
Keri Carrera  
Notary Public



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ASSIGNMENT AND AGREEMENT

**COPY**

Signature Page for Third Inventor

Date: 8/31/99

Gurtej Singh Sandhu  
Gurtej Sandhu

United States of America )  
State Idaho )ss.:  
County of Ada )

On this 31 day of August, 1999, before me personally came Gurtej Sandhu, to me known to be the individual described in and who executed the foregoing instrument, and acknowledged execution of the same.

Lisa Boyer  
Notary Public

